IAP7 Rec'd PCT/FTO 17 JAN 2006

PTO/SB/21 (09-04)
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		Application Number	10/553,893
TR	ANSMITTAL	Filing Date	10/21/2005
	FORM	First Named Inventor	Chistyakov
	- *	Art Unit	Not Yet Assigned 2821
	ali correspondence after initial	Examiner Name	Not Yet Assigned PHILOGEN
	cited References) Pages in This Submission	7 Attorney Docket Number	ZON-005USN
Total Number of	Pages in This Submission	·	
		ENCLOSURES (Check all	that apply)
Amendm Arian	fter Final ffidavits/declaration(s) n of Time Request Abandonment Request on Disclosure Statement Copy of Priority	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attronsy, Revocation Change of Correspondence / Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on Ct	Status Letter X Other Enclosure(s) (please Identify below): PTO Form 1449 (4 pgs.); Copies of References B1-B2 and C1-C1-4; and Return Receipt Postcard.
	CICNA	TURE OF APPLICANT, ATTO	DNEY OF ACENT
Firm Name			
	Rauschenbach P	atent Law Group, LLC	
Signature	Fut Paus	Sell	
Printed name	Kurt Rauschenbach		
Date	January 13, 2006		Reg. No. 40,137
sufficient postage	at this correspondence is t as first class mail in an en	ERTIFICATE OF TRANSMISS being facsimile transmitted to the USPT evelope addressed to: Commissioner for	ION/MAILING O or deposited with the United States Postal Service with r Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on
the date shown b Signature	7 7	Canalell	
Typed or printed	I Maria Danisak		Date January 13, 2006

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTD to process) an application. Confidentially is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 11.4. This collection is estimated to 2 hours to complete, including pathering, preparing, and submitting the completed applications of the confidence of the confidence

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Chistyakov

SERIAL NO.: 10/553,893 GROUP NO.: Not Yet Assigned FILING DATE: October 21, 2005 EXAMINER: Not Yet Assigned

TITLE: High Density Plasma Source

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. BOX 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.97, Applicants hereby make of record the references listed on the accompanying Form PTO-1449 for consideration by the Examiner in connection with the examination of the above-identified patent application. Copies of References B1-B2 and C1-C14 are enclosed.

REMARKS

In accordance with the provisions of 37 C.F.R. §1.97, this statement is being filed (CHECK ONE):

(1)	within three months of the Filing Date of a national application other than a continued prosecution application under § 1.53(d); or within three months of the date of entry of the national stage as set forth in § 1.491 in an international application; or before the mailing of a first Office Action on the merits; or before the mailing of a first Office Action after the filing of a request for continued examination under § 1.114; or
(2)	after the period defined in (1) but before the mailing date of a Final Action or Notice of Allowance, and $$
	the Statement required under § 1.97(e) below, OR
	the fee set forth in § 1.17(p), namely \$180.00, is included herein, or
(3)	after the mailing date of a Final Action or Notice of Allowance but before the payment of the Issue Fee, \mbox{AND}
	the Statement required under § 1.97(e) below; and

Information Disclosure	Statement
Serial No.: 10/553,893	
Page 2 of 2	

the fee set forth in § 1.17(p), namely \$180.00 is included herein.

It is respectfully requested that each of the references shown on the attached Form PTO-1449 be made of record in this application.

STATEMENT

As required under §1.97(e), Applicants, through the undersigned, hereby state either that [check the appropriate space]:

- That each item of information contained in the Information Disclosure Statement
 was first cited in any communication from a foreign patent office in a
 counterpart foreign application not more than three months prior to the filing
 date of the Information Disclosure Statement; or
- 2. That no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the Information Disclosure Statement was known to any individual designated in §1.56(c) more than three months prior to the filing of the Information Disclosure Statement.

FEE AUTHORIZATION

Applicants believe that there is no fee associated with this submission, however should it be determined that a fee is due, the Commissioner is hereby authorized to charge the missing fee to our Deposit Account No. 501211.

Respectfully submitted.

Date: January 13, 2006 Reg. No. 40,137

Tel. No.: (781) 271-1503 Fax No.: (781) 271-1527

Doc-1954v1

Atty/Agent for Applicant(s)
Rauschenbach Patent Law Group, LLC

Post Office Box 387 Bedford, MA 01730

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Substitute for form 1449A/PTO		Co	mplete if Known
		Application Number	10/553,893
INFORMATION DISCLO	SURE	Filing Date	10/21/2005
STATEMENT BY APPLI	CANT	First Named Inventor	Chistyakov
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Sheet 1 of	4	Attorney Docket Number	ZON-005USN

			U. S. PATENT	DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ^{2 (F Answer)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	Al	US- 3,666,982	05-30-1972	Wiegand, Jr.	
	A2	US- 4,953,174	08-28-1990	Eldridge, et al.	
	A3	US- 5,015,493	05-14-1991	Gruen	
	A4	US- 5,247,531	09-21-1993	Muller-Horsche	
	A5	US- 5,795,452	08-18-1998	Kinoshita, et al.	
	A6	us- 5,821,548	10-13-1998	Hinchliffe	
	A7	US- 5,846,883	12-08-1998	Moslehi	
	A8	us- 6,093,293	07-25-2000	Haag, et al.	
	A9	^{US-} 6,124,675	09-26-2000	Bertrand, et al.	
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	A11	^{US-} 6,296,742 B1	10-02-2001	Kouznetsov	
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	A17	US- 6,853,142 B2	02-08-2005	Chistyakov	
	A18	US- 6,896,773 B2	05-24-2005	Chistyakov	

		FOREIGN F	ATENT DOC	JMENTS		
Examiner initials*	Cite No.1	Foreign Patent Document Country Code ³ (Number ⁴ Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
	Bl	WO 98/40532	09-17-1998	Chemfilt R & D		
	В2	WO 01/98553 A1	12-27-2001	Chemfilt R & D		
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1	Examiner Signature		Date Considered	
	*EXAMINER:	Initial if reference considered, whether or not citation is in conformance with MPEP 609	Draw line through	citation if not in conformance and not

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				Application Number	10/553,893	
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	Substitute for form 1448A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Uso as many sheets as necessary)	ICANT	First Named Inventor	Chistyakov		
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			U. S. PATENT		
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (Finome)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	A19	US- 6,896,775 B2	05-24-2005	Chistyakov	
	A20		10-19-2004	Chistyakov	
	A21	US- 2004/0060813 A1	04-01-2004	Chistyakov	
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Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ (Number ⁴ Kind Code ⁵ (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Peges, Columns, Lines, Where Relevent Pessages or Relevant Figures Appear	Τ°
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the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CPR 197 and 198. The information is required to obtain or retain a benefit by the public which is to file good by the USPTO to process) an application. Confedentially is governed by 58 U.S. C. 120 and 37 CPR 1.14 This collection is settimated to take? I have to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time pur certain to complete this form antifer suggestents for requiring this burden, should be sent to the Crisi information Officer. U.S. Patient and Trademark Office. U.S. Department of Commerce, P.O. Box 1459, Alexandria, VA. 22313-1459. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patients, P.O. Sox 1459, Alexandria, VA. 22313-1459.

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	Substitute for	form 1449B/PTO				Complete If Known
					Application Number	10/553,893
	INFOF	RMATION DI	SCLO	SURE	Filing Date	10/21/2005
	STAT	EMENT BY A	APPLI	CANT	First Named Inventor	Chistyakov
					Art Unit	Not Yet Assigned
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$\overline{\ }$	Sheet	3	of	4	Attorney Docket Number	ZON-005USN

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-lesue number(s), publisher, citly and/or country where published.	T²
	CI	BOOTH, ET AL., The Transition From Symmetric To Asymemtric Discharges In Pulsed 13.56 MHz Capacitively Coupled Plasmas, J. Appl. Phys., 15 July 1997, Pgs. 552-560, Vol. 82, No. 2, American Institute of Physics.	
	C2	BUNSHAH, ET AL., Deposition Technologies For Films And Coatings, Pgs. 178-183, Noyes Publications, Park Ridge, New Jersey.	
	C3	DAUGHERTY, ET AL., Attachment-Dominated Electron-Beam-Ionized Discharges, Applied Physics Letters, 15 May 1976, Pgs. 581-583, Vol. 28, No. 10, American Institue of Physics.	
***************************************	C4	GOTO, ET AL., Dual Excitation Reactive Ion Etcher For Low Energy Plasma Processing, J. Vac. Sci. Technol. A., Sep/Oct 1992, Pgs. 3048-3054, Vol. 10, No. 5, American Vacuum Society.	<u> </u>
•••••••••••••••••••••••••••••••••••••••	C5	KOUZNETSOV, ET AL., A Novel Pulsed Magnetron Sputter Technique Utilizing Very High Target Power Densities, Surface and Coatings Technology, 1999, Pgs. 290-293, Vol. 122, Elsevier Science S.A.	
	C6	LINDQUIST, ET AL., High Selectivity Plasma Etching Of Silicone Dioxide With A Dual Frequency 27/2 MHz Capacitive RF Discharge.	
	C7	MACAK, Reactive Sputter Deposition Process Of Al203 And Characterization Of A Novel High Plasma Density Pulsed Magnetron Discharge, Linkoping Studies In Science And Technology, Pgs. 1-2.	
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	C9	MOZGRIN, ET AL., High-Current Low-Pressure Quasi-Stationary Discharge In A Magnetic Field: Experimental Research, Plasma Physics Reports, 1995, Pgs. 400-409, Vol. 21, No. 5.	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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	Substitute for form 1449B/PTO				Complete If Known		
					Application Number	10/553,893	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			SURE	Filing Date	10/21/2005		
			CANT	First Named Inventor	Chistyakov		
				Art Unit	Not Yet Assigned		
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く	Sheet	4	of	4	Attorney Docket Number	ZON-005USN	

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Т		
	CII	SHERIDAN, ET AL., Electron Velocity Distribution Functions In A Sputtering Magnetron Discharge For The Ex B Direction, J. Vac. Sci. Technol. A., Jul/Aug 1998, Pgs. 2173-2176, Vol. 16, No. 4, American Vacuum Society.			
	C12	STEINBRUCHEL, A Simple Formula For Low-Energy Sputtering Yields, Appl. Phys. A., 1985, Pgs. 37-42, Vol. 36, Sprigner Verlag.			
		Encyclonedia Of Low Temperature Plasma, Pg. 119, Vol. 3	L		
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